

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor: DELLER

Application No.: 09/647,659

Filing Date: 10/04/2000

Examiner: GRAYBILL, DAVID E

Group Art Unit: 2814

For: ALIGNMENT PROCESSING MECHANISM AND SEMICONDUCTOR
PROCESSING UNIT WITH ALIGNMENT PROCESSING MECHANISM

RESPONSE TO FINAL OFFICE ACTION

Box AF
Commissioner for Patents
Washington, D.C. 20231

Applicants are filing this submission and a request for continued examination in response to the final Office Action mailed May 21, 2002. Applicants are enclosing a one month extension of time to extend the due date to September 21, 2002. This date falls on a Saturday so Applicants are timely filing this submission on the following Monday September 23, 2002. The application is to be amended as follows.

AMENDMENT TO THE CLAIMS

Please add new claim 18 to the application as shown by the enclosed attachment.

No additional fees are due as a result of this amendment.